

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10711649	
	Filing Date		2004-09-24	
	First Named Inventor	Kawamura		
	Art Unit	2813		
	Examiner Name	Monica D. Harrison		
	Attorney Docket Number	SSIT-114		

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Attorney Docket Number		SSIT-114	

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	1	T. FUKUDA ET AL., "A Novel Method of Removing Impurities from Multilevel Interconnect Materials" (XP001232125), Japanese Journal of Applied Physics, March 2004, pgs. 936-939, Vol. 43, No. 3, Japan Society of Applied Physics, Tokyo, Japan	<input type="checkbox"/>
	2	I. KATO ET AL., "New Method to Improve Electrical Characteristics of Low-k Dielectrics in Cu-Damascene Interconnections" (XP008060635), 2003 Advanced Metallization Conference, pgs. 699-704, Materials Research Society, Warrendale, PA	<input type="checkbox"/>
	3	J. A. LUBGUBAN ET AL., "Supercritical Carbon Dioxide Extraction to Produce Low-k plasma Enhanced Chemical Vapor Deposited Dielectric Films" (XP012032705), Applied Physics Letter, December 2, 2002, pgs. 4407-4409, Vol. 81, No. 23, American Institute of Physics, Melville, NY	<input type="checkbox"/>
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¹ See Kind Codes of USPTO Patent Documents at www.USPTO.GOV or MPEP 901.04. ² Enter office that issued the document, by the two-letter code (WIPO Standard ST.3). ³ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁴ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁵ Applicant is to place a check mark here if English language translation is attached.

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STATEMENT BY APPLICANT**
(Not for submission under 37 CFR 1.99)

Application Number	10711649
Filing Date	2004-09-24
First Named Inventor	Kawamura
Art Unit	2813
Examiner Name	Monica D. Harrison
Attorney Docket Number	SSIT-114

CERTIFICATION STATEMENT

Please see 37 CFR 1.97 and 1.98 to make the appropriate selection(s):

- ☒ That each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement. See 37 CFR 1.97(e)(1).

OR

- ☐ That no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of the information disclosure statement. See 37 CFR 1.97(e)(2).

- ☒ See attached certification statement.
- ☐ Fee set forth in 37 CFR 1.17 (p) has been submitted herewith.
- ☐ None

SIGNATURE

A signature of the applicant or representative is required in accordance with CFR 1.33, 10.18. Please see CFR 1.4(d) for the form of the signature.

Signature	/Kristi L. Davidson/	Date (YYYY-MM-DD)	2006-04-07
Name/Print	Kristi L. Davidson	Registration Number	44643

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 1 hour to complete, including gathering, preparing and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. **SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.**

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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/711,649
Applicants: Kawamura et al.
Art Unit: 2813
Title: **METHOD FOR SUPERCRITICAL CARBON DIOXIDE
PROCESSING OF FLUORO-CARBON FILMS**
Attorney Docket: SSIT-114
Confirmation No.: 5648

Cincinnati, Ohio 45202

April 7, 2006

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
STATEMENT OF CERTIFICATION UNDER § 1.704(d)

Each item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart application and to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in 37 C.F.R. § 1.56(c) more than thirty days prior to the filing of the Information Disclosure Statement

Applicants do not believe that any fees are due in connection with this submission. However, if such petition is due or any fees are necessary, the Commissioner may consider this to be a request for such and charge any necessary fees to Deposit Account No. 23-3000.

Respectfully submitted,

WOOD, HERRON & EVANS, L.L.P.

By: /Kristi L. Davidson/

Kristi L. Davidson, Reg. No. 44,643

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